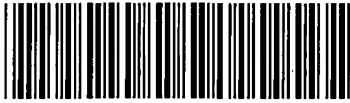


**Search Notes**

Application/Control No.

10/500,244

Examiner

Steven D. Maki

Applicant(s)/Patent under  
Reexamination

IWASAKI, SHIZUO

Art Unit

1733

**SEARCHED**

Class	Subclass	Date	Examiner
152	209.18		
	209.22		
	209.25		
	902		
	Dig.3		
updated	above	1/7/2007	<i>SDM</i>

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
none	1/7/2007	<i>SDM</i>